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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Fumihito OKA

Application S/N: 09/925,626

Filed: August 10, 2001

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: Group Art Unit: 2811
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: Examiner: S. Hu
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For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE, CRYSTALLINE SILICON THIN FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT

Honorable Assistant Commissioner
for Patents
Washington, DC 20231

RECEIVED
MAY 28 2002
TC 2800 MAIL ROOM

Sir:

In response to the Official Action dated April 25, 2002, wherein restriction has been required, applicant hereby elects Group I (claims 1-13) for prosecution in the above-identified application without traversal.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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Date: May 23, 2002